

Notice of References Cited	Application/Control No. 10/607,064	Applicant(s)/Patent Under Reexamination KOBAYASHI, KENYA	
	Examiner Michelle Estrada	Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,968,610	10-1999	Liu et al.	427/579
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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